



1 Inventor: Dan G. Custer et al.

2 Title: Polishing Systems, Method of Polishing Substrates, and Methods
3 of Preparing Liquids for Semiconductor Fabrication Processes

4 Assignee: Micron Technology, Inc.

5 Serial No.: 09/298,160

6 Filing Date: April 22, 1999

7 **SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

8 **PURSUANT TO 37 C.F.R. §§1.56, 1.97 AND 1.98**

9 In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention is
10 directed to the United States patent listed on the attached Form PTO-1449,
11 and copies of which are attached.

12 Citation of these references is respectfully requested.

13 Respectfully submitted,

14 Dated: 10/13/99

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GP-1763

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PTO/SB/21 (6-98)
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Total Number of Pages in This Submission

9

Application Number	09/298,160
Filing Date	April 22, 1999
First Named Inventor	Dan G. Custer
Group Art Unit	1763
Examiner Name	Unknown

Attorney Docket Number MI22-1172

ENCLOSURES (check all that apply)

<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input type="checkbox"/> Amendment / Response <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input checked="" type="checkbox"/> Information Disclosure Statement <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/ Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Assignment Papers (for an Application) <input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition Routing Slip (PTO/SB/69) and Accompanying Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Small Entity Statement <input type="checkbox"/> Request for Refund <input type="checkbox"/> Remarks	<input type="checkbox"/> After Allowance Communication to Group <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input checked="" type="checkbox"/> Additional Enclosure(s) (please identify below): <div style="border: 1px solid black; padding: 2px; width: 100%;">Postcard</div>
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Firm or Individual name	David G. Latwesen, Ph.D.
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Date	10/13/99

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